UNITED STATES PATENT AND TRADEMARK OFFICE

Att. Docket No. 10191/1690

Appl. Serial No.

09/762,985

Confirmation No. 2674

Title

DEVICE AND METHOD FOR

ETCHING A SUBSTRATE USING

AN INDUCTIVELY COUPLED PLASMA

Applicant(s)

Volker BECKER et al.

Filed

May 8, 2001

TC/A.U.

1763

Examiner

Luz L Alejandro Mulero

Docket No.

10191/1690

Customer No.

26646 I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail

Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

in an envelope addressed to: Mail Stop MENDMEN)

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Date

Signature:

AARON C. DEDITCH

Della

(33,865)

TRANSMITTAL AND PETITION TO EXTEND

SIR:

Transmitted herewith for filing in the above-identified patent application is an Amendment.

This is also a Petition Under 37 C.F.R. § 1.136(a) to extend the three-month response date by three months from May 23, 2005 to August 23, 2005.

The Commissioner is authorized to charge the appropriate fees of \$1,020.00 (which includes the \$1,020.00 fee for the three-month extension) to Deposit Account No. 11-0600, and is also authorized, as appropriate and/or necessary, to charge any additional fees (including any Rule 136(a) extension fees) or credit any overpayment to Deposit Account No. 11-0600. Two duplicate copies of this transmittal letter are enclosed for these purposes.

Respectfully submitted,

By:

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